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Positive Image forming composition

(57) A positive image forming composition is disclosed, which comprises (e) e compound generating an ecid by undergoing the action of light or heat and (b) et least one compound selected from the N-sulfonylamide compounds represented by the following formula (I) or (ID:

L1 - (SO2 - NR2 - CO - R1)

L1 - (CO - NR2 - SO2 - R1)... wherein n is an integer of from 1 to 6; R, represents an arometic group or an alkyl group; L1 represents an aro-

matic group or an elkyl group when n is 1, or L1 represents a polyvalent linkage group constituted of nonmetal atoms when n is from 2 to 6; and R2 represents a tertiary alkyl group, en alkoxymethyl group, an arytmethyl group or an alloyolic alkyl group (or (c) a pol-ymer having constitutional units represented by the following formula (III):

> - SO₂ - NB₂ - CO -CHD

wherein R₁ represents a tertiary alkyl group, an alkoxymethyl group, an arylmethyl group or an elicyclic elkyl group.

Description

The present invention relates to a positive image forming composition used in the manufacturing process of a lithographic printing plate or a semiconductor device such as IC, in the production of a circuit substrate for liquid crystal, e

ogrephic person place on a semiconductor device stand as it, in the production of a circuit assessment in equal crystal, of thermal head or the like, and in other photolabilication processes.

The present invention relates to a photosensitive composition which can be used for a lithographic plate end, more particularity, for a lithographic plate material which makes development-processing unnecessary and has suitability for

direct recording of digital signels from a computer.

As positive image forming compositions or positive working lithographic materials, compositions comprising alkali
soluble resins and naphthogunonedazide compounds as photosensitive material have generally been used.

source rearrs and naprimoquinonecastics compounds as protosensive misstral new generally been used.

In a positive photorisalist of this freigning type which is constituted absistaly of a modular real nat of quinonedistics compound, the novolak reals nat os as to provide high resistance to plasma extring and the naprithoquinonedistics compound can require the discolorion project of an afast-solution provider reals and functions as a discolorion inhibitor.

compound can reduce the dissolution upeed of an alkala-soluble novolak resin and functions as a dissolution inhibitor. And, the naphthoquinondistick shat a characteristic of generaling a carboxylic said upon irradiation with light to lose to the billipy to inhibit dissolution, thereby heightening this solubility of a novolak resin in alkali. Usually, such a material forms a positive image by underground the dissolution and the said of the said

From the aforementioned points of view, a large number of positive photoresist compositions which each comprise a novolak resin and a raphthoquinonediazide type photorensitive material have hitherto been developed and put to

a novolak resin and a naphthoquinonodiacide type photosensitive material have hitherto been developed and put to practical use. In the micro-likhography for the lines having a width of the order of 0.8-2 µm, those compositions have accomplished satisfactory results.

On the other hand, the integration degree of an integrated circuit has become higher and higher in recent years, so that the micro-lithography for superfine patterns having a line width of helf micro-or or below has come to be required in the production of ceremon substrates for VLSI and the files. In order to achieve the resolution required therein, the production of ceremon products of the production of the product of the production of the uniform of the production of the production

In a case where a conventional resist comprising a novelected and a naiphthoquinonalization compound is used for forming patients by the fittingstarby using far uttervible light or an exceiment lesser beam. It is difficult for the light to care charmed part of the result of bosonies are ordered resist in order part of the result obscures a provider resist end naiphthoquinonalization have strong absorption in the fair.

ultravioler region, so that such a resist has low sensitivity and can merely provide a patient profile having a tapered happe.

As a means for sching the atoresment and protein the hemically smpfilled resist compositions described, e.g.,
Al IS Patient 4,491,058 and European Patient 0,249,139 can be used. The hemically smpfilled positive resisted positive resisted hemically smpfilled positive resisted positive resisted.

altions refer to the pattern forming materials of the type which generate acids in the impdated area upon exposure or adiation, such as of unitrovide Eight, to cause a readinion resident packed as casisty, the they meeting a distinction of acidstrip the active the packed and unitroduced and unitroduced with active rediction. By virtue of this sout-billy difference, a petern can be termed on a substrate oracle with the material of the forecome had been designed.

As a surplex of a chamically symflect relat composition, mention may be made of the combination of a compound couplate of generally and early probability ferrits in called a photocody demosition, benefits with scaled or on D, in couplate of general probability of the compound of the

49 with a silyl seter compound (JP-A-60-10247) and the combinations of photoacid generators with silyl ether compounds (JP-A-60-97548 and JP-A-60-121446). Those combinations have a quantum yield greater than 1 in principle, so that they arbitrating enablish;

As exemples of a similar system to the above, which is stable upon isstange at from temperature but documposes by healting in the persons of an early or size sociality in a relaising mode to make the systems described, as a limit, mention may be made of the systems described, as a, in PA-69-45409, PA-69-50605, PA-68-20000, PA-68-200000, PA-68-20000, PA-68-200000, PA-68-200000, PA-68-200000, PA-68-200000, PA-68-200000, PA-68-200000, PA-68-200000, PA-68-200000, PA-68-200000, PA-68-20

Those positive resists of chemical amplification type form resist patterns by undergoing development after a heat treatment in the presence of acids generated from photoacid generators by exposure to light. However, those resists

have a problem that, in proportion at the standing partied from the exposure it the heat treatment (PEB treatment) becomes longs, changes are produced in not only the sansiship but also the profile earth the line widn to a resist pattern obtained after development since the generated acid diffuses farther and the descrivation of the acid by basic impurises in the embourance proposed at the resist sustained.

In general, the image forming materials as described above, which include positive working ithographic materials constituted basically of a novolain resin and a quinconduzide compound, from image by undergoing the development with an alkall after appount. However, the development stop sometime pelmy of time and labor, and what is worse, it is undescribed for workers' satisfy and environmental preservation because it uses a developer of high alicatinity (generally of the contract of the co

6 Although the printing pietes using those positive working photosensitive compositors can certainly produce images without select development or by being breast with heusies levels alone, they ere apt to give rise to ecumning during the practical printing operation. Therefore, it is required to make further improvements in them. More specifically, for the reduction of scumming, it is required to relarge a difference between the hydrophilicity (ink repetiency) and the lopophility (ink receptive), secondly to heldster the hydrophilicity.

In the field of lithography, on the other hand, there has recently been enhanced interest in thographic materials which enable he so-called direct platemating, or the direct recording of digital signals from a compater or a printing plate satisfiering lease heares in the visible region or the infrared region device, instead of the systems using conventional light sources for strawbolde lights.

The photopolymers sensitive to near infrared reys are disclosed in European Patent 0,444,766, JP-A-63-208036 and JP-A-63-274952. Further, European Petent 0,682,483 discloses the positive image forming material which has

However, those printing plates have a defect that, although their sensitivities to infrared leser are sufficient, they generate sourn in non-image areas upon long-term storage, particularly under a condition of high temperature and high humidity.

As mentioned above, the conventional positive image forming photosensitive materials of the type which require no developer have a problem of being act to generate sourn, particularly upon long-term storage.

Therefore, one object of the present invention is to provide a positive image forming composition suitable for a pho-

to resist composition which is reduced in the resist pattern change depending on the standing period from the exposure off the heat treatment.

Another colored of the present invention is to provide a positive image forming composition useful for the production

of an offset printing plate which has high sensitivities to from rays in the UV region to those in the infrared region and no scurming in the non-image erea.

A further closed of the prevent invention is to provide a positive image forming composition containing an edd clear-

able compound which can be produced with ease and at a low price.
A still another object of the present invention is to provide a lithographic printing plate which can afford stain-free printed matters ever when it undergoes no development effect exposure.
A still further object of the present invention is no provide a printing object which has high sensitivity to light of www-

A six surrier copics or me present invention is to provide a printing piete which has high sensitivity to light of weeklengths longer than 350 min, expectably to wichib and infrinted lasers beams, excellent establity upon storage and no scurin the non-image erea. As a result of our intensive studies, it has been found that, when the substituent on the N storm of an N-sulfornie-

mide structure is a particular group, the sultonylamide structure is decomposed efficiently by an acid to provide a hydrophilic NH group.

Also, it has been found that the combined use of an N-sultonylamide compound having a particular substituent

group and an edd generator can solve the resolution deteriorating problem which is caused by lapse of time after exposo sure in a resist for micro-lithography use. Purther, if has been found that a printing plate having practical sensitivity to a visible light source and no scurming

In the non-intege erice can be produced using the continesson of an N-sultonylemide compound heving a particular substituted regious with en edd generator. Evidence of the production of the production of the production of a printing plate having printical sensitivity and no sourcempt on serial refused describing de natiles the production of a printing plate having printical sensitivity and no sourcempt on

non-image area. Further, it has been found that, when e polymer having such N-sulfonylemide structures as to have e particular subsituant on the nitrogen etom is used in combination with an acid generator, the resultant crimina clebs can have sensitivity high enough for prectical use and generates no soum in the non-image area even when undergoes no development after exposure.

Furthermore, If her been found that, when a polymer having such h-sufforylamide sinctures as to have a particular substitute on the ritingen extent is used in combination with an acid generator and an interned absorbing of resultant printing plate can have practically sufficient sensitivities to leser beams in the infrared region and generates no sourin in the non-image area.

Also, It has been found that the combination of an acid generator with an N-sufronjamide polymer having particular groups as the substituents on the integer atterns can provide a high-speed image terming composition with its entire to practically useful light sources and can also form images by undergoing conventional development-processing after exposure.

More specifically, it has been found that the problems described above can be solved by using the following constitutions [1] to [9], thereby achieving the present invention:

[1] A positive image forming composition comprising, (e) a compound generating an acid by undergoing the action of light or heat and (b) at least one compound selected from the N-sulfonylsmide compounds represented by the following formula (i) or (ii):

$$L_1 \cdot (SO_2 \cdot NP_2 \cdot CO \cdot P_1)_n$$
 (1)

$$L_1 \cdot (CO \cdot NR_2 \cdot SO_2 \cdot R_1)_0$$
 (II)

wherein n is an integer of from 1 to 6; R₁ represents an eromatic group or an alkyl group; L₁ represents an eromatic group or an elkyl group; then n is 1, or 1, represents a polyvalent linkage group constituted of normatel etoms when n is from 2 to 6; and R₂ prosessents a territory alkyl group, an an eloxymethyl group or an

alicyclic ellyl group.

[2] A positive image forming composition according to the constitution [1], wherein the N-sulfonylamide compound

of formule (1) or (1) contains as Pi_e a 5-butyl group or e 2-2-dimethyl-4-4-dimethylbutyl group. [3] A positive image forming composition according to the constitution [1], wherein the Neutionylamide compound of formule (1) or (1) contains as R₂ a bencytoxymethyl group, a combruxymethyl group, a 2-dibuxyethyl group, a

methoxyethoxymethyl group, a tetrahydropyranyl group or e tetrahydrofuranyl group.

[4] A positive image forming composition according to the constitution [1]), wherein the N-sultonylamide compound of formula (1) or (1) contains as P₂ a p-methoxybearyl group, e 2.4.6-trimsthoxybearyl group, e pjereonyl group or

of unimate (v. et you can as a or a prime unique you you, or a system interesting the percent group or a 9-erithrary imathyl group, or a prime unique you you go a 9-erithrary image to mring composition eccording to the constitution [1], wherein the N-suttorylamide compound of formula (if or (ill contains as P₂ a cyclohexyl group or a distance, the prime group.)

(6) A positive image terming composition according to any one of the constitutions (1) to (5), wherein the add generating compound (a) is at letter one compound selected from the group consisting of access compounds having tribal oneity is abstituents, indontum salts, sufficient compounds having tribal oneity is abstituents, indontum salts, sufficient selections.

[7] A positive image forming composition eccording to any one of the constitutions [1] to [6], further comprising eithigh molecular organic binder which is insoluble in water but soluble or at least swellable in an equeous alkaline solution.

gold a constitutions [1] to [6], further composition according to any one of the constitutions [1] to [6], further comprising en infrered absorbing dvs.

infered absorbing dys.

[9] An image forming composition comprising (e) e compound generating an acid by undergoing the action of light or heat and (c) a polymer having constitutional units represented by the following formule (iii) in the main chain or side chains:

wherein R₀ represents eitertierly elkyligroup, an elkoxymethyligroup, en erylmethyligroup or en elicyclic elkyligroup.

In the mechanism of image berration by the use of a lithographic method is according to the present invention, the perforant resident on the integers and in each subsequent structure of an Headborgheimide compound or a polyse may having the subhyplamide groups is sign life the integers attempt to the section of the week of them an ead generate used tegether with the polymer to provide a production but group, and the property of the interest of the subgraphic material is changed greatly from Ink-incapativity to hydrophilotiv. The change enables the sociation of the sourmino coordina in the northease area.

Further, the combined use of the present eoid-decomposable N-suftcrylamide compounds and acid generators, aspicially those sensitive to light of wavelengths in the visible orland infrared regions, can arsure high sensitivities to visible orland infrared field, particularly to least beams, in the positive image formation.

Moreover, the combined use of the present N-sulfonylamide polymer having particular substituents with an acid generator ensures high sensitivities to practically useful light sources, especially to light in the intraved region as well. The present N-sulfonylamide compounds represented by the foregoing formula (f) or (file artillustrated below).

This immediation of is delithred econotic group represented by R₁ or I₁, in the case of In-1 incutes acromed, hydrocondor process, and ensures the description groups, and process process, and or process processing in the processing of the pro

used alkyl group represented by H₂ or L₂ in the case of re-1 includes alkyl groups containing 1 to 25 carbon atoms, in particular, singhth-chain or brenchde alkyl groups containing 1 to 8 carbon atoms, such as a mathyl group, an ethyl group, an isopropyl group and a huyly group, are preferred over the others. When L₁ in the case or her or R₁ represents a substituted correlation group, a substituted argonitis had to the carbon and the substitute of the substitute of the carbon group, a substituted argonitis had the carbon and the substitute of the substitute of the carbon group, a substitute of the substi

contained as substituted groups in the substituted aromatic hydrocarbon group and the substituted aromatic heterocyoil circum presented by P₁ or t₂ in the case of n = 1.

When n is from 2 to 6, L₁ represents an optionally substituted polyvalent linkage group consisting of normatal

The polyvalant linkaga group represented by L₁ is constituted of from 1 to 60 carbon atoms, from 0 to 10 ribrogen atoms, from 0 to 50 surpen atoms, from 1 to 100 hydrogen atoms, and from 0 to 20 suffur atoms. Specific examples of such a linkage group include combinishings of two or more of the structural units literated below.

50

e polyvelent naphthalane and e polyvelent enthracene.

Specific countries of a substituted group wind/or on the primeter on the polyvalent linkings group as inclinal above linkings slight groups providing from 19 20 control entities, used an entity and styll groups, extending groups contending from 5 to 16 cattorn above, such as phenyl servi depthy groups; a hydroxing group, a centraling group; as substituted to groups; and hydroxing-bridge groups; and a school-bridge groups; and hydroxing-bridge groups; and a school-bridge groups; and a school-

y carbonyl and cyclonesyloxycarbonyl groups; a cyano group; and carbonate groups, such as a Houtyl carbonate group.

The indecular weight of e compound represented by formuta (I) or (II) ranges from 400 to 5,000, preferably from 500 to 3,000.

As for the tertiery elkyl group represented by R₂, those containing from 4 to 20 carbon etoms, such as a t-butyl group and a 2,2-dimethyl-4,4-dimethylbutyl group, are examples thereof.

As for the allowy motify of the substituted or unsubstituted allowymethyl group represented by R₂, allowy groups containing from 1 to 6 cuthon storms. such as method you and strong groups, are examples thereof. As for the groups so which the silvoury motify can be substituted, alloy groups containing from 1 to 6 cathon storms, silvoury groups and or make groups such as privary and matching groups are examples thereof. Additionally, the substituted allowymethy the substituted allowymethy and the substituted allowing the substituted allowing the substituted allowymethy the substituted allowing the substituted

group can be a group dividing into branches at the site of the custon atom taking with the nitrogen atom, such as 2ethory-ethyl, 4-thyl-ethyl-thetyl-thoring for instructiongraphing group.

Of those eliksymethyl groups, e methoxymethyl group, a 2-chrosysthyl group, a methoxyethoxymethyl group, a benryksymethyl group, a tetrahydroximary group and a sterahydroxymyl group are preferred in particular.

As for the any) motivity of the substituted or unsubstituted erythrethyl group represented by H_2 , enyl groups containing from 6 to 14 carbon atoms, such as phenyl, naphthyl end enthrenty groups, are examples thereof.

As examples of e group by which the anyl molety can be substituted, mention may be made of elkoxy groups containing from 1 to 4 carbon atoms and alkyl groups containing from 1 to 4 carbon etoms.

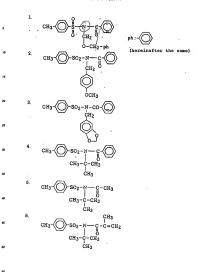
Specific examples of the substituted or unsubstituted anytimativity group ex mentioned above include e-p-methoxybenzyl group, a 2,4,6-trimethylbenzyl group, a piperonyl group and e9-enthrenylmethyl group.

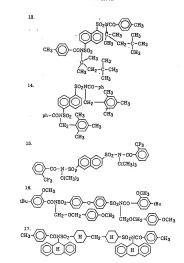
As a substituted or unabstituted alliptical solving roup represented by R₀, those containing from 5 to 7 carbon etums can be employed. Examples of a substitutent group which can be presented no such groups include a methody group, a habogen etem end e benzame ring tused together with the elbhalfs ring the properties of the propertie

a dibenzosuberyl group.

Specific examples of N-sulfonylamide compounds used in the present invention are illustrated below, but these

examples are not to be construed as limiting the scope of the invention in any way.





19.

Synthesis examples of the N-sulfonylemide compounds used in the present invention are described below.

Synthesis Example A-1

Synthesis of Compound 1 exemplified above:

In a three nocked fasis, 13.7 of 14-for-telementation/fleenzemick and 200 or of 14 No-dimetalysostamide were placed, and stirred at room temperature. Thereis, 5 of 16 rietlystamine was acted with stirring. At the conduction of the addition of brieflystamin, 10.9 of othersyl childromethyl either was further acted. Then, the stirring was continued by 2 hours, and the resulting reaction tolution was poursel into water to yield crystals. These crystals were filtered off, end encrystallized from a hazame-believe mixture. Thus, white orgatist were obtained in the amount of 16 p. mp. 99-101°C.

Synthesis Example A-2

Synthesis of Compound 4 exemplified above:

In a 2-liter three necked flask, 9.0 g of N-(t-butyl)-p-toluenesulfonylamide and 100 ml of N,N-dimethylacetamide

were placed, and thereto was added 20 g of socium hydride (60 % oby sociation). Further, 5.75 g of beneroy choicide, was added disciplate with addings and send was socioid and no beath. After the orderise addition was cooled in an obeath. After the orderise additions was continued by additional two hours. Then, the ice beth was believe every and the reaction mixture ease sutther selected for 5 hours at cornt temperature. The resultant reaction solution was admitted with 500 mt of water, and cannot advised with 500 mt of water, and cannot with 50.75 fact of eithy admits. The oil thus obtained was purified with a siting get column. Yeld 4.2 g, mp, 73-400.

The appropriate proportion of the present compound represented by formula (f) or (iii) in the total composition (excluding a coeting solvent) is from 5 to 95 weight %, preferably from 10 to 70 weight %, and more preferably from 15 to 80 weight %.

The polymers having the constitutional units represented by the foregoing formula (III) in the present invention are

Bussette ballow in detail.

The larm projems' as used herein retires to a maximomercule which is derived by mutually combining many, a.g.,
10, 100, 1000 or mos, smaller molecules and has a molecular weight of non about thousands to about millions. The
smaller molecules to be combined mutually as generally called "informents" or "programs", and the mutual consistent in resident of south molecular in the consistent of south of south molecular in the consistent of south molecular in the consistent of south molecular interval interval in the consistent of south molecular interval interval

or more of an appropriate constantional repeating unit, which is, in many cases, the shockand terms in all an encourse or proporties are a list shirtly instantiful. The addited in the chemical propriate, the reaction the constituent removants, the characteristics and the normalisate or polymer are upleen in Oders, Principles of Debmestaging, and Est, John Welly and Sons, New Nork (1981), and Employated or Polymer Selevice and Employated, by New York (1981), and Employated in Polymer (sherine and Employated), but Welly and Sons, New York (1981), and Employated in Polymer (wherein all the monomer units are the same) and copolymer (whether in the orm one shed of monomer make are properly.

The present constitutional unit represented by the foregoing formula (III) may be present in the main chain or side chains of a polymer.

The fer liary alloy (group represented by P₀ in bormula (III) is an unsubstituded stratary alloy (group heriting 4 to 20 cares 20 born attorns or a substituded testing yalloy (group. Distollate examples of use in exitory, alloy froup include a 1-buby) (group end o 2.2 dimethyl-4,-dimethylsuby) (group, As for the substitutins which can be present on those groups, a halogometron such as substitution of testing and the contract of testing and the contract groups under a principle group are partly group or matching (group match).

When R₁ represents a subfluid or unsubstitud disciprishing group has allowy molecy of such group included 20 those combining in the dischor storms, such as methory and storp groups. As for the buddless of reseal on such as allowymethy group, an elly group containing 1 to 6 action atoms, an ellowy group and an eight group, such as planty or realthing tours, are examples thereof. In the substitude allowymethy group, group, thereigh to colors atom statistical to the refrequent action at a branch point, such as 1+butsay-stryl, fetal/productional and terrelity organizagroups, are also included.

35 Of those alkozymethyl groups, methoxyethoxymethyl, benzyloxymethyl, tetrahydrofureryl, tetrahydropyranyl, methoxymethyl, ethoxymethyl end 1-ethoxyethyl groups are preferred in particular.

The anyl molety of a substituted or unsubstituted enylmethyl group represented by R₀ includes anyl groups having 6 to 14 carbon etoms, such as phenyl, naphthyl end enthernyl groups.

As for the substituent present in the substituted anylmethyl group, an alkoxy group having 1 to 4 carbon atoms and

49 en alkyl group having 1 to 4 carbon etoms are examples thereof. Specific examples of such a substituted or unsubstituted arytmethyl group include p-methoxybanzyl, 2.4,6-frimethybenzy, bytenzyl and 9-methoxybanzyl, 2.4,6-frimethybenzy, bytenzyl and 9-methoxybanzyl, 2.4,6-frimethybenzyl, 2.4,6-frime

When R₃ is a substituted or unsubstituted alicyclic alkyl group, the alicyclic alkyl group includes those having 5 to 7 carbon atoms. As for the substituent(s) such a group can have, a methoxy group, a phenyl group, a halogen atom and 4s a benzene ring fususd together with the alignatic ring ere scenariose thereof.

Suitable examples of a substituted or unsubstituted alloyetic alkyl group include a cyclohexyl group and a dibenzosubaryl group.

When the present polymer has the constitutional units of formula (III) in the form of et least one molety selected from those represented by the following formulae (IV), (V) and (VI), the image forming composition of the present inversion can achieve more large-pile effects:

wherein R4 represents an aromatic group or an alkyl group; L3 and L4 are the same or different, and each of them rep-

resents e polyvelent organic group which is constituted of normetal atoms and links the constitutional unit of the formula (IV), (V) or (VI) to the polymer skeleton; and R₂ represents a tertiary alkyl group, an elikosymethyl group, an erythethyl group or an elicytic labyl group.

The present polymers having constitutional units represented by the foregoing formulate (IV) to (VI) are illustrated

The unsubstituted or substituted controls group representably R₁ includes both entropolic and heteropolic and relating capus. As for heteropolic among large control group, an about period and service as exemption and the exemption of the description of the exemption of the description of the exemption of the

When R_i is a substituted cohecopies commissic group, as substituted interropoles commiss group, or a substituted shift group, the additional of those groups calcular allowing groups in the 1 to 1 does not some, such as an embrough and group in 1 to 1 does not some, such as an embrough and group in 1 to 1 does not some, such as a final groups are found in the substitute of the substitute and the substitute of the substitu

The polyvalent linkage group constituted of mormetal storus which is represented by L₂ or L₄ is intended to include those constituted of 1s 60 caches entered, by 1s 00 to Syrtogen storus, or 50 cacyges attorus, 1s 1s 00 to Syrtogen enterus or 0 to 20 cacyges attorus, 1s 1s 00 to Syrtogen enterus end 0 to 20 suther atoms. Specifically, the linkage groups formed by combining two or more of the following structural units are examples or 0.1 and L₄.

polyvalent naphthalene, polyvalent anthracene

When the polyvieted triange group here substituted (i), examples of such substituted (i) related subj groups hering it to 0 cannot name, such as meltyl and religion groups; e) substituted (ii) and in the substituted of such as substituted or substituted or such as substituted or substi

The present polymers having constitutional units represented by the foregoing formula (III) can be synthesized uculyby polymerizing monomeric units which have various reactive groups on the moledes corresponding to the linkage or or up to a or L.

Thereis, L₀ or L₁ is listed to a reacting or polymerizing group useful for the polymerization reaction in produce a polymer having the constitutional term represented by the brosping hamilese (Fig. 10); This commission is under supposed to the produce a polymerization reaction include is hydroxyl group, an exposure carbon group, are entire to extraory (struct, prosping devided from first promotions, cuts as an anxiety in an embarytise, and in some carbon group, are entire to extraory (struct, prosping devided from first promotions, cuts as an anxiety in this is a methal profit and structure of the product of the product of the structure is the contained as a structure of the interest in method as call and a structure of the interest in a function devided programs of polymer. Examples of such as tracting group of considering with functional proper attended to a previously programs (any first product of such as tracting group of considering with functional proper attended to a previously program (any first product of such as tracting group of considering with functional proper attended to a previously program (any first product of such as tracting group of considering with functional proper attended to a previously program (any first production and as any first production and any first production and any first production and as any first production and any first production any first production and any first production and any first product

Most of general polymers can the synthesized using monomers whether his above-reduced reading groups used to polymers above reduced to reduce the polymers of the polymers polymers polymers of the polymers of the polymers operated by the polymers operated polymers polymers operated polymers operat

such a polymer can be in the range of thousands to millions.

Of those polymers, polyecrylate, polymerbacrylate, polyacrylamida, polystyrene, polyester, polyurethane, phenol resins and econy resins are perferred over the others.

In a group of polymers well subset for the passes invention, exprise adoptimens, methacytic acid polymers, polyriyemes and zoyamintépolymers out to hinducide beause of their develop in tretuction, their sease of perhapsis poor of physical properties, and their capacity to provide satisfactory performance. A suitable method to proparation of the polymer are resided above consists in the sacidate opherestance of the tretuctual solid charmes (all) which is no to combined stable a monomer mointy such as an exprisit, methacolystal, expressión, methacolystals or systematio, methacolystals, Secolfo scarriede of such a monomer excludated setulosation in the Substandards services i

M-3.

M-4.

M-5.

35

10

M-13.

M-14.

M-16.

M-17.

M-18.

$$CH_{Z} = CH \underbrace{\begin{array}{c} So_{Z}NCO - \\ C - NH - \\ O \end{array}}_{C(CH_{3})_{3}}$$

$$\begin{array}{c} \text{M-20.} \\ \text{CH}_2 = \text{CH} \\ \text{C} - \text{NH-} \\ \text{C} - \text{CH}_2 \\ \text{CH}_3 \\ \text{C(CH}_3)_3 \end{array}.$$

M-21.

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M-25

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Specific examples of a commonme useful for coop/immetation reaction with the N-sulfroylumide monomer as reclused above include spriler or metheropies cold acrept on emberger load states (e.g., methyle deprete or method, yet, e.g., principal propriet or method principals, but an experience or method principals, principals, principals, querity or method, 2-deplicatively principals or method principals, principals, querity or method, 2-deplicatively principal or method principals, principals, querity or method, 2-deplicatively principal or method principals, and princi

yullanes having vinyl groups, such as methicarylorjougopylimathoxysillene syrano; maleic anhydride, 4vinyloridine, 2-methicaryloroyethane-1-alicinic good and salts thereof, anyloridinis, and vinyl ethere, such as ethyl vinyl ether. However, these examples are not to be condered as laming on the acops of the invention. Other examples of an acrylic monomer and an acryloridide monomer are recited in Encystogedia of Polymer Science, 2nd Ed., vol. 1, 6 on 182, Oke 27, 242 and 245.

As anche group of oxylames which are useful bosculas of their seas of syntheses and their accollent cheesity, mention may be made of onlywerhates propered from does, disconnectes and chair schedules. In the preparation of such polymers, particularly useful inscutants are N-authorisemed advantates having displacety or disconnect group. The properties of the properties of

As examples of other useful polymers, mention may be made of polyesters. The polyesters can be synthesized by reference to FW Billmeyer, Entrody of Polymer Spicings, John Willipy and Sons, New York (1984), and on on, Specific amples of a substituted Neutron/samile which can be advantageously used as a starting material for the synthesis 20 of polymethance probyester are situated to below.

243-303.

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U-2.

HOCH2CH2

N-CH2

OCHPF

HOCH2CH2

N-CH2

OCH

U-3.

HOCH₂CH₂

HOCH₂CH₂

HOCH₂CH₃

U-4.

HOCH₂CH₂N So₂NCOCH₃ CH₂OCH₂CH₂CCH₂CCH₂CCH₃

19

20

25

40

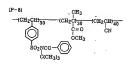
However, the compounds it ustrated above should not be considered as limiting on the scope of the substituted Nsuifonylamide compounds suitable for the present invention.

The proportion of the total N-sulfonylamide groups (-SO₂NR₂CO-) in the present polymer can be from 0.01 to 99 % by weight. From the practical point of view, however, it is in the range of 0.1 to 98 % by weight.

The weight-everage molecular weight of the present polymer is generally from about 1,000 to about 1,000,000, but can exceed such a limit. Preferably, the present polymer has its molecular weight in the range of about 5,000 to about 1,000,000.

The present constitutional units represented by formula (III) can be incorporated in both side chains end main chain

of a polymer as well as in either the side chains or the main chain of a polymer. Specific examples of a polymer having constitutional units of formula (III) used in the present invention are illustrated below. However, the invention should not be construed as being limited to these examples. Additionally, the figures in the discovering studyund formula are mole fractions.



$$\begin{array}{c} (P-13) \\ \\ -(CH_2)_6 - N \\ \hline \\ (P-14) \end{array}$$

$$\begin{bmatrix} (CH_2)_2 & O & O \\ (CH_2)_2 & O & O \end{bmatrix} - SO_2 - N - C - O & O \\ O & O & C(CH_3)_3 \end{bmatrix}$$

Synthesis Examples of polymers having N-sulfonylamide groups according to the present invention are described below.

Synthesis of Monomer (Exemplified Compound M-2):

- in a 1-liter three necked flask were placed 30.0 g of N-t-butyl-p-tolusnesuffonamide, 17.4 g of triethylamine, 2.0 g of dimethylamine, virial and 300 mil of acatonitrite.
- The flask was cooled in an ice bath, and 18.0 g of methacryl chloride was dropped thereinto over a one-hour period with sirring.
- After the dropping, the stifring was continued for 3 hours et norm temperature, and allowed to stant owneright. Then, the recuting position was poured into 300 mild or water, extracted with 500 mild et 8/m scentar, dried over magneature suffets, and then concernitated. The concernited obtained was recrystalized from a 3.1, by volume, mixture of hexame and eithyl acested. Thus, 2.5 of withe crystalls bring the melting point of 64°C were obtained.

Synthesis Example B-1

Synthesis of Polymer having N-Sulfonylamido Groups (P-4):

- In a 100-mil thrae necked flack, 7.2 g of Compound M-2.1.0 g of methodyloxypropylimethopylimen and 16 g of ethyl abotel were placed, and lepit at 65°C with stirring under a sheam of nitrogen. Thereio, 7.8 mg of 2,2°-activity,2,4dimethyl-larcontrille) was addod, and the plinting was continued. After a lapse of two hours, 20.0 mg of 2,2°-activity,2,4dimethyl-larcontrille) was sufficient added, and subjected to 4-hour string. Then, the reaction solution was cooled to 20° room tamponatus, and pound into 500 mf of methods. A solid precipitate (colorwer) was fifteen off at and risk. The
 - room tamparature, and poured into 500 ml of methanol. A solid precipitate (polymer) was filtered weight-average molecular weight of the polymer determined by GPC was 3.8x10⁴. Yield: 8.1 g.

Synthesis Example B-2

35 position (excepting a coating solvent).

as Synthesis of Polymer containing N-Sulfonylamido Groups (P-5):

- In a 100-mi three necked flack, 8.0 g of Compound M-2, 0.45 g of glycicyl methecryste and 16 g of ethyl sociatals was placed, and kept at 85°C with stirring under a ulreamer or integor. Thereby, 5.8 mg of 2.2-acabsit2.4-d-methyl-leonoritivity was adode, and the direiny was continued. After a lapse of two hours, 5.5 mg of 2.2-acabsit2.4-d-methyl-leonoritivity was bodder, and the direiny was continued. After a lapse of two hours, 5.5 mg of 2.2-acabsit2.4-d-methyl-leonoritivity was humber added, and subjected to 4-hour stirring. Then, the reaction solution was cooled to room temporatum, and proved into 500 m of omstandor. A self-originate (solution) was fitted off, and origin. The weight
 - everage molecular weight of the polymer determined by GPC was 4.3x10⁴. Yield: 5.6 g.
 Those polymers having the contestutional units of formula (III) are used in a proportion of generally from 5 to 99 weight %, preferably from 10 to 99 weight %, nor preferably to mile 15 o 99 weight %, to the total ingredients of the com-
- Wifin respect to the compound which is decomposed by undergoing the action of light or heat to generate an acid (abbreviated as a photocoid generator, hereinatiler), a compound selected properly from among a photophoto calcinic polymerization, a photoinitistor for photo radical polymerization, a photodecolorie for dyes, a photo dispersion properly income photosoid-producing compounds used for microresist end the like, and e mixture of two or more 40 of the above another can be used in the orsent invention.
 - As examples of compounds underlyides as those agents, mention may be made of the disaction, mails described, e.g., in 61, 10-times, CRISCO_SER_ENT_ 18-07 (1979), end 1 5 line et in_Pattern E. 17 (1990), end 1 4 - 1-14 (1990), end 1 - 14 - 14 (1990), end 1 - 14 (199

des described, e.g., in K. Meier et et., J. Bad, Curing, 13(4), 26 (1986), T.P. Gill et al., Ingrg. Chem., 19, 3007 (1980), D. Astruc, Acc. Chem. Res., 19(12), 377 (1896), and JP-A-2-181445; the photoacid generators having o-nitrobenzyl type protective groups described, e.g., in S. Hayase et al., J. Polymer Sci., 25, 753 (1967). E. Reichmanis et al., J. Polymer Sci., 25, 753 (1967). ymer Sci., Polymer Chem. Ed., 23, 1 (1985), Q.Q. Zhu et al., J. Photochem., 36, 85, 39, 317 (1987), B. Amit et al., Tetrahedron Lett., (24) 2205 (1973), D.H.R. Barton et al., J. Chem. Soc., 3571 (1965), P.M. Collins et al., J. Chem. Soc., Perkin I, 1695 (1975), M. Rudinstein et el., Tetrahodron Lett., (17), 1445 (1975), J.W. Walker et el., J. Am. Chem. Soc., 110, 7170 (1988), S.C. Busman et al., J. Imaging Technol., 11(4), 191 (1985), H.M. Houlihan et al., Macromolecules. 21, 2001 (1988), P.M. Colins et al., J. Chem. Soc., Chem. Commun., \$32 (1972), S. Havape et al., Macromolecules. 18, 1799 (1985), E. Raichmanis et al., J. Electrochem. Soc., Solid State Sci. Technol., 130(6), F.M. Houlihan et al., Macromolecules, 21, 2001 (1988), European Patents 0,290,750, 0,046,083, 0,156,535, 0,271,851 and 0,388,343, U.S. Patants 3.901.710 and 4.181.531, JP-A-60-198538 and JP-A-53-133022; the compounds penerating sufficiency of photolysis represented by iminosulfonates and the fike as described in M. Tunooka et al., Polymer Precrimts Japan, 35(8), G. Berner et al., J. Rad. Curino. 13(4), W.J. Mills et al., Coating Technol., 55(697), 45 (1983), Alzo, H. Adachi et el. Polymer Preprints Japan. 37(3). European Patents 0.199,672, 0.084,515, 0.199,672, 0.044,115 and 0.101,122. U.S. Patents 4,618,564, 4,371,605 and 4,431,774, JP-A-64-18143, JP-A-2-245756, and JP-A-4-365048; and the disasfona compounds described, e.g., in JP-A-61-166544.

thesis. (1), 1 (1990). A Abad et et., <u>Tetrahadron Lett.</u> (47) 4555 (1971). D.H.R. Barton et et., <u>J. Chem. Soc.</u> (C), 329 (1970), U.S. Patent 3,779,778 and European Patent 0,126,712, can be employed, too.
Of the compounds recited above as those which centrate exists by undersoning the action of light or heat, the fol-

lowing compounds are used to particular advantage:

A trihalomethyl-substituted exazote compound of the following formule (PAG1), or a trihalomethyl-substituted striazine compound of the following formula (PAG2):

wherein R^1 is a substituted or unsubstituted eryl or alkeryl group, R^2 is a substituted or unsubstituted aryl, alkeryl or alkyl group or $-C(Y)_3$, and Y is a chlorine or bromine atom.

Specific examples of such compounds are illustrated below, but these examples should not be construed as limiting the scope of the present inventor.

$$\begin{array}{c} \text{CI-} & \begin{array}{c} \text{CH=CH-} & \begin{array}{c} \text{N-N} \\ \text{CPAG1-1} \end{array} \end{array}$$

$$\begin{array}{c} \text{CH}_3 & \begin{array}{c} \text{CH=CH-} \\ \text{CPAG1-2} \end{array} \end{array} \begin{array}{c} \text{N-N} \\ \text{CPAG1-2} \end{array}$$

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(2) An iodonium selt of the following formula (PAGS), e sulfonium selt of the following formule (PAG4), or a diazonium selt:

wherein Ar¹ and Ar² are each a substituted or unsubstituted anyl group. Examples of a substituent suitable for the anyl group include an alkyl group, a halosikyl group, a cycloalkyl group, an anyl group, an alkoxy group, a nitro group, a carboxyl group, an alkoxycarbonyl group, a hydroxy group, a mercapto group and a halogen atom.

R3, R4 and R5 are each a substituted or unsubstituted alkyl or anyl group. Preferably, each of them is a 6-14C aryl group, a 1-9C alkyl group or a substituted derivative thereof. Examples of a substituent suitable for the aryl group include a 1-8C alkoxy group, a 1-8C alkyl group, a nitro group, a carboxyl group, a hydroxy group and a halogen atom, and those for the alkyl group include a 1-8C alkysy group, a carboxyl group and an alkosycarbonyl

group. Z' is a counter anion, such as BF₄', AsF₆', PF₆', SbF₆', SiF₈²', ClO₄', a perfluoroal/anesultonic acid anion such as CF_xSO_x, a pentathorobenzenesulfonic acid anion, a condensed polynoclear aromatic sulfonic acid anion such as naphthalene-1-sulfonic acid anion, an anthraquinonesullonic acid anion, or a dye containing sulfonic acid group.

However, the counter ion as Z should not be construed as being limited to the above-recited ones. Further, two among R3, R4 and R5, and two of Ar1 and Ar2 as well, may combine with each other via a single bond or a substituent.

Specific examples of such compounds are illustrated below, but these examples should not be construed as limiting the scape of the present invention.

$$\begin{array}{cccc}
(PAG4-1) & BF_4 \\
(PAG4-2) & S^+ & PF_5 \\
(PAG4-2) & S^+ & A_5F_6
\end{array}$$

The above-illustrated onium salts of formulae (PAG3) and (PAG4) are known compounds, and can be prepared using the methods described, e.g., in J.W. Knapczyk et al., J. Am. Chem. Soc., 91, 145 (1969), A.L. Maycok et al., J. Org. Chem., 35, 2532 (1970), E. Goethes et al., Bull. Soc. Chem. Bolg., 73, 546 (1964), H.M. Leicester, J. Am. Chem. Soc., 51, 3587 (1929), J.V. Crivello et al., J. Polym., Polymer Chem. Ed., 18, 2677 (1980), U.S. Patents 2,807,648 and 4,247,473, and JP-A-53-101331. (3) A disultone compound represented by the following formula (PAGS) or an immosulfonate compound repra-

sented by the following formula (PAG6): Ar2-SO2-SO2-Ar4

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(PAG5)

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wherein Ar³ end Ar⁴ ere each a substituted or unsubstituted any group, R⁶ is a substituted or unsubstituted alley for any group, end A is a substituted or unsubstituted alleyfame, alternyfame or enyfame group. Specific exemples of such compounds erell llustrated below, but these examples should not be construed as limiting the scope of the present invention.

$$Cl$$
 \longrightarrow SO_2 \longrightarrow Cl $(PAG5-1)$. H_3C \longrightarrow SO_2 \longrightarrow SO_2 \longrightarrow CH $(PAG5-2)$

The foregoing compounds which are decomposed by the action of light or heat thereon to generate exist are used in the proportion of from 0.001 to 40 weight %, preferably from 0.1 to 5 weight %, and more preferably from 0.1 to 5 weight %.

Best on the total weight of the composition (excluding a coating solvent).

Further, the spectral centritizers as recited below are added to induce sensitivity to the wavelengths at which the photosacid generator used has no spectral absorption; that is, wavelengths longer than fair utraviolet region, and thereby it becomes possible to confer the sensitivity to 1 or g-fine upon the procent photosensitive composition. Specific exempts

ples of such a sportal sensitate include beaupherson, pp-internativipleaminocherospherson, pp-internativipleaminocherospherson, pp-internativipleaminocherospherson, pp-internativipleaminocherospherson, perinne, perinne,

es limiting on the scope of spectrel sensitizers usable in the invention.

For the purpose of conferring the sensitivity to light of wavelengths in the visible region upon the present composi
tion, known spectral sensitiers such as cynnic dyse, mercoganine dyse, squaryflum dyse, courserin dyse, xarthone

dyes, Julcidine dyes, pryylum dyes, eardine dyes, Michter's latone, thickarthone and scridone can be used. Besides the above-prickd special settletters, dyes arbibring hier aboutprion in he Internet region are used to education, expecially in preparing a photoserable composition for an internet sensitive lithographic plate, because they enable the production of acids under the action of infrared rays when they are used in combination with the photo-toxical generations litterated above.

With respect to intersed-ebsorbing dyes or pigments used for the foregoing purpose, the dyes or pigments capable of effectively absorbing infrared rays of wavelengths of four 760 nm 1, 200 nm are examples thereof. Preferably, the dyes or pigments used are those having their absorption maxima in the wavelength region of 760 to 1,200 nm.

As for such dyes, the commercially evaluate dyes and the dyes known in the literature, an, <u>Sennya Binnar</u> (the senanting of the literature, and <u>Senantial Binnar</u> (the meaning of the literature, and <u>Senantially</u>, eac dyes, metal complex and dyes, pyrazolone and dyes, enthraquinone dyes, phthalocyenine dyes, carbonium dyes, outhonium did even, methics of get, opering dyes, metal filiciates complexes and the literature are engilyately.

Cit fixes dyes, the opinine dyes open only an IPA-59-12294, P.A-59-94555, JPA-69-202229 and JP.A-579757, the matters dyes described, e.g., in JPA-59-12294, P.A-59-94555, JPA-69-202229 and JP.A-579757, the matters dyes described, e.g., in JPA-59-173969, JPA-69-181690 and JPA-69-19495, the napimisity opinion dying described, e.g., in JPA-69-17279, JPA-69-2940, JPA-69-19476, JPA-69-2940 and JPA-69-693744, the squaryfurn dyes described, e.g., in JPA-69-5112792 and the openine dyes described in British Patters (44.975 per orderably village).

Also, the near inferred disording sensitizes disordbard II U.S. Patent 5,155,335 can be used to obsertage, Further, the substitude Systemathibility private disordbard II U.S. Patent 5,381,345,4 in the International System 24,000 can be used to secretary the International System 4,000 can be used to secretary the International System 4,000 can be used to secretary the International System 4,000 can be used to secretary the International System 4,000 can be used to secretary the International System 4,000 can be used to secretary the International System 4,000 can be used to secretary the International System 4,000 can be used to secretary the International System 4,000 can be used to secretary the International System 4,000 can be used to secretary the International System 4,000 can be used to secretary the International System 4,000 can be used to secretary the International System 4,000 can be used to secretary the International System 4,000 can be used to secretary the International System 4,000 can be used to secretary the International System 4,000 can be used to secretary the International Systems 4,000 can be used to secretary the International Systems 4,000 can be used to secretary the International Systems 4,000 can be used to secretary the International Systems 4,000 can be used to secretary the International Systems 4,000 can be used to secretary the International Systems 4,000 can be used to secretary the International Systems 4,000 can be used to secretary the International Systems 4,000 can be used to secretary the International Systems 4,000 can be used to secretary the International Systems 4,000 can be used to secretary the International Systems 4,000 can be used to secretary the International Systems 4,000 can be used to secretary the International Systems 4,000 can be used to secretary the International Systems 4,000 can be used to secretary the International Systems 4,000 can be used to secretary the International Systems 4,000 can be used to secretary the International Systems 4,000 can be u

As other examples of dyes of the foregoing type, mention may be made of the near inferred absorbing dyes represented by formulae (i) and (ii) disclosed in U.S. Patent 4,758,993.

Of those dyes, the cyanine dyes, the squerylum dyes, the pyrylum selts and the nickel thiolate complexes are preferred in particular.

As for suitable dyes, oil cofors and basic dyes are examples thereot. Specifically, Oil Yallow 9103, Oil Prink 9102, Oil Green 19.0 Oil Black 95.0 Oil Black

The pigments which can be used in the present invention hadude the commercially wellade pigments and the pigments described in the iterature, e.g., Solici Index (CL) Heritodis Saithin Gerror Birrar (the meaning of this title is "Handbook of the Latest Pigments"), compiled by Nippon Carror Giptus (Votal in 1977, Selsini Gerror Originator Carror Carr

metris end caution black can but used. Of these poliments, caution black is preferred over the others.
Those pignettes may be used without carderping may entered never be explicited to a surface treatment, method by the explicated to a surface treatment, as method of costing the pignett surface with a resin or see.

I method of making a surfactant others the beginner surface or a method of the prince resints or a method of the prince resistant or the prince resistant or the prince of the prince resistant or the prince of the prince resistant or the prince re

and Applications of Metal Scep*), published by Salwal Shobo, the book cited above, antitled "Insatsu Ink Glutsu", published by CMC Shuppan in 1984, and the book cited above, entitled "Salshin Garryo Oyo Gijutsu", published by CMC Shuppan in 1984.

The size of pigment particles is preferably from 0.01 to 10 µm, and more preferably from 0.05 to 1 µm. In particular, the preferable preferable of the stability of pigment dispersion in the stability of pigment dispersion in a coating composition for a photosensitive leyer, it is undestrained for the pigment to have a particle size smaller then

0.01 µm; while the particle sizes greater than 10 µm are undesirable from the viewpoint of uniformity in the image recording layer.

The signment dispersion can be prepared using known dispersion techniques for producing ink, tone and the like. As for the dispersion practines used prenty, on useasonic disperser, or eard mit, on entition mill, a pear int. it is super mill, o ball mill, an impatire, a disperser, a KO mill, a cotoid mill, a Dynaton, a three-ord roll mill and a pressure kneeder or examples hereof For details of despersion bedrings the above-cited book entitled "Salarih Canyo Dyn Gigstu".

(poblished by OMC Stuppen in 1989) can be referred to.

The dyes or gyments as rotated below can be added to.

The dyes or gyments as rotated below can be added by the present composition in a proportion of from 0.01 to 05 swipt %, perfectly from 0.0 to 10 weight %, in the case of dyes and to min 1.0 to 10 weight % in the case of dyes are from 0.01 to 10 to 10 to 10 to 10 to 10 weight %, perfectly from 0.01 to 10 to

Those dyes or pigments may be incorporated in the sama leyer as other ingredients, or in a leyer provided sepa-20 rately from the leyer containing other ingredients.

With respect to night motivate organic bindra usable in the present composition, organic bindra which are insufation in water but solicitize or a less stated bin in an illustrate exposure calcular (see that they rup to easile a failed resimal are exampless thereof. More specifically a movidar tenin, a hydrogeneter nocolatir resin, an another-proposition resin, a polythyrogentyremal, is balogine or adhy-laboration or polythyrotyremal, a hydrogeneter nocolatir resin, and seem and the proposition of the

these rasins should not be construed as limiting the scope of the invantion in any way.

Of those a kali-soluble resins, a novolek resin and a polyhydroxystyrene) are preferred in particular. The novolek each can be obtained using specified monomers as men component and subjecting them to the addition condensation on reaction with addithyles in the presence of an ecidic cetalyst.

As to the aposition mornous, anomalicity/days companyable, such as phanot, crossic (e.g., m.coust, p.-pousul and co-cross), pietrate (e.g., 2-5-systend, 3-5-yestend, 3-5-yest

Specific examples of aldehydes which can be used include formaldehyde, paraformatidehyde, acetalehyde, project containing to the containing the project containing to the project containing to the project containing to the project containing the project

methylbrancialbyde, p-methylbranzialehyde, m-mercenzacenyoe, n-menyoenzacenyoe, o-menyoenzacenyoe, methylbranzialehyde, p-mbuybranzialehyde, p-mbuybranzialehyde, n-mbuybranzialehyde, n-mbuybranziale

Those delitylets can be used alone or as a misure of two or more thereof. As for the acidic celelyst which can be used, hydrochic cad; suthing cad; social coid cell cell cell cell acid are warmight shroot.

It is destable for the provision reality colaried in the foregoing manner to have their weight-everage microcal in the many cell color 50,000. When the weight everage microcaler weight is below 1,000, a decrease of time of the cell cells are cells and the cells cells

opment speed becomes low. The weight-average molecular weight particularly suitable for the novolak resins is from 2,000 to 20,000. Additionally, the weight-average molecular weight is defined as the value determined by get permeation chrome-

tography on e polystymes besis.

Those elief-actuble receins as recited above may be used as a mixture of two or more thereof. The proportion of sleal soubtle receins to the total ingredients (excluding a solvent) in the present composition is from 0 to 97 % by weight, preferably some 5t 1 on 93 % by weight.

To the present composition, a high molecular organic binder can be added, if needed. As for the high molecular

organic binder, although any of known polymers may be used, polyecrylete, polymethacrylete, polymerylemide, polystyrans, polyeter, polyurethana, a phenol resin, a novolek rasin, a poly(hydroxystyrena) and an epoxy resin are especially suitable.

Of those high motecular organic binders, polymers insoluble in water but soublis or at least swallable in an expecus s effect location are useful in cases where the photosensitive materials according to the present invention are used for the image formation with an elikal developed, (which is also called an elikal-locative priority) Septimis respike of such a polyymer include a novolak read, an acetone-pyrogatiol resin, a polythydrosystyrene), and a carboxyl-containing methserul/or entain and eliversives thereous.

These organic high molecular binders are used in a proportion of from 0 to 97 weight %, preferably from 0 to 90 weight %, to the total ingredients of the photosensitive composition (excluding a coating solvent).

weight se, to the coal ring extents of the protosensions composition (excluding a coating servent).

The present N-sulforystamide compounds which function as dissolution inhibitor can be used together with conventional dissolution inhibitors.

More specifically, besides the acid-cleavable sulfonamide compounds used in the present invention, the compounds having other linkages capable of being dieeved by an acid, such as C-O-C and C-O-Si linkages, may be used to in combination.

As for conventional compounds having solid-deavable C-O-C or C-O-Si linkages, compounds of the following types (a) to (i) are known to be effective:

(a) compounds which each contain at least one orthocarboxylic edd ester and/or carboxylic acid arride acetal group and have polymericibility to bram polymers containing those groups as cross-linking elements in their main chain or se substituents in their slick chain;

(b) ohygomeric or polymeric compounds which each contain repeated scetal and/or ketal groups in their main chain, (c) compounds which each contain at least one end other or N-a-Dylaminocarbonate group, (d) cyclic acetals or ketals of 3-featopeaters of 8-featopament.

(a) compounds containing silyl other groups.

(f) compounds containing silyl encl ether groups,
 (a) monoscetal or manokatal compounds whose ecetal or ketons component has the solubility of from 0.1 to 100

g/f in a developer, (h) tertiary elcohol ethers, and

(i) carboxylic acid estars or cerbonates of tartiary allylic or banzylic alcohols.

make or originic polymers contenting Qu-O or QU-SI transges, Mole opherately, mole opportunity include originic polymers contenting Qu-O or QU-SI transges, mole opherately originized originization originized originized originized originization originized originization originized originized originization originized originization originization originized originization origination origination originization originization originization originization originization or

so preliatedly 0 to 20 weight %, to this total impredients of the photosensible composition (excepting a tokens). When the compounds continining delicitescapital CO-C or CO-SI integes are polyment, they can be used in place of a part or all of the foregoing alleaf-solubla restrict.

The oriented photosensible corrosotion can harber comprise other impredients, such as a dye, a pignent, a place-

The present photocentrive composition can further comprise other ingredients, such as a dye, a pigment, a plasficizer, a surfactant, a photosensitizer and a compound having at least two phenotic OH groups to promote dissolution as in a developer, if needed.

In using the present composition in a costed state, a plate-form material basing high dimensional stability is used as support. Specific assumpted or specific assumpted set put a support include plane, platels forminated which polyathylane, polypropylane, polystymna, etc.), plates of metale (e.g., eluminum (including aluminum alloys), zer, coppositivylane, polypropylane, polystymna, etc.), plates of metale (e.g., eluminum (including aluminum alloys), zer, coppositivylane, polypropylane, polystymna, etc.), plates of metale (e.g., eluminum (including aluminum alloys), zer, coppositivylane, polypropylane, polystymna, etc.), plates of metale (e.g., eluminum (including aluminum alloys), zer, coppositivylane, polypropylane, polystymna, etc.), plates of metale (e.g., eluminum (including aluminum alloys), zer, coppositivylane, polystymna, etc.), plates of metale (e.g., eluminum (including aluminum alloys), zer, coppositivylane, polystymna, etc.), plates of metale (e.g., eluminum (including aluminum alloys), zer, coppositivylane, polystymna, etc.), plates of metale (e.g., eluminum (including aluminum alloys), zer, coppositivylane, polystymna, etc.), plates of metale (e.g., eluminum (including aluminum alloys), zer, coppositivylane, polystymna, etc.), plates of metale (e.g., eluminum (including aluminum alloys), zer, coppositivylane, polystymna, etc.), plates of metale (e.g., eluminum (including aluminum alloys), zer, coppositivylane, etc.), plates of metale (e.g., eluminum (including aluminum alumin

per), pleefs (Time (e.g., Time of cellulors discrete, cultiuse inscrete, cultiuse propionate, cultiuse buyers, cultiuse inscrete, cultiuse inscrete, cultiuse inscrete, cultiuse inscrete, polyphythes inspringheits, polyphytheins, po

In a case where the export has a most author, seporally as alternam nation, it is desirable that he support to explicate the seather framement, such as graning transmiss, of larging selements in response activation obtained to explicate the seather selement of the seather selement selement of the seather selement seleme

e.g., enhancement of hydroghnicity.

The prosets composition prompered by dissolving the observementored ingredients in a proper solvent, and costed
on a sport as noticed above, Suitable searches of a solvent sused therein noticed eighteen districted, opticitizations,
on a sport as noticed above, Suitable searches of a solvent sused therein noticed solvent of the solvent sport of the control of the contro

Also, e surfactant can be added to the solvent es recited above. Specific examples of such a surfactant include nonionic surfactants, such as polyoxyethylene alkyl ethers (e.g., polyoxyethylene lauryl ether, polyoxyethylene stearyl ether, so polyoxyethylene cetyl other, polyoxyethylene cleyl ether), polyoxyethylene alkyl end ethers (e.g., polyoxyethylene octyl phenol ether, polyoxyethylene namyl phenol ether), polyoxyethylene-polyoxypropylene black copolymers, sorbitan fatty acid esters (e.g., sorbitan monolaurate, sorbitan monopalmitate, sorbitan monostearate, sorbitan monooleate, sorbitan triolegte, sorbitan tristearate) and polycxyethylenesorbitan fatty acid esters (e.g., polyoxyethylenesorbitan monolaurate, polyoxyethylenesorbitan monopalmitate, polyoxyethylenesorbitan monosteerete, polyoxyethylenesorbitan trioleete, polycryetrylenesorbitan tristearate), fluorine-containing surfactants, such as Eftop EF301, EF303 and EF352 (commercial names, products of Shin-Akita Kasei K.K.), Megalac F171, F173 and F177 (commercial names, products of Dai-Nippon Ink & Chemicals, Inc.), Florad FC430 and FC431 (commercial names, products of Sumitomo 3M Co., Ltd.), Asahiguard AG710, Surfion S-382, SC101, SC102, SC103, SC104, SC105 and SC106 (commercial names, products of Asahi Glass Company, Ltd.), organosiloxane polymers, such as KP341 (code name of Shin-etsu Chemical Co., Ltd.), and acrylic or methecrylic acid (co)polyment, such as Polytlow No. 75 and No. 95 (commercial nernes, products of Kybeishe Yushi Kagaku Kogyo K.K.). The amount of those surfactants edded is generally not greater then 2 parts by weight, preferably not greater than 1 part by weight, per 100 parts by weight of the total solide in the present composition. Those surfactants may be added along or as a mixture of two or more thereof.

The photosensible materials presented from compositions according to the present invention, although can prodictal integes without a develope; can exert see the place statistic integes formation with a develope as well as a desire large without a develope; can exert see the place of the control of the place of the control reservation. The shall develope used for such a purpose in an eliability account activation control integers and see all control integers and casts. A count of the place of the control of the place of the control of the place of the control of the place casts. A count setting y place place, so count secondary promptate, errorcular setting promptate, ammonium secondary of policytates, souther medicalists or exposure ammonium, a primary secondary promptate, ammonium secondary of policytates, souther secondary place of the count of the place of th

secompass or eigm source of active beams used for the exposure of the present photosentifes composition, manifor may be maded of an utar arright pressure, medium or low pressor manurary large, e metal hadde large, a serion large, a chemical large, a carbon are large, various later devices for visible, utraviolet and other reys, a fluorescent large, a chemical large and sun light. As for the redeficions, electron beams, X-reys, into beams and for utilisativel rays are

examples thereof. As a light source for photometrists, price; livery and DeepUV (light are preferably used. Further, soonming or pulse exposure using high density every bearen (laser beam or electron bearing can be be employed enent of the present composition. As for laser bearen used for such appears, Hi-No leser, segment leser, regards lacer, He-Old leser and for densities lacer are exemples beared. For interest addison, on the other hard, sold leser semiconductor laser devices capable of emitting interest range, particularly in the wavelength region of 760 to 1,200 nm., can be analysed.

EXAMPLES

The present invention will be illustrated below in more detail by the following examples, but the scope of the invention should not be construed as being limited by these examples. Additionally, in the following examples, all "%" are by weight uries so therwise indicated.

EXAMPLES 1 TO 6 AND COMPARATIVE EXAMPLES 1 TO 4

This surface of a 0.30 mm bits duminim plate was garried with a rijon touch and a water suspension of purrise provider of 40 mm, and throughly was alread with water. This is destinating plate as estable to be passing Speak of 50 miles of 50 miles

Composition of Photosensitive Solution:

N-Sulfonylamide compound in Table 1	1.0 g
m/p-Cresol resin (m/p ratio: 6/4)	200
p-(Phenylamino)benzenediazonium hexafluorophosphete	0.5g
Crystal Violet	0.01 g
Methyl ethyl ketone	18 g
2-Methoxyethanol	6 g

The first operating of each photocontine volution are 20 pin? The first oblighted photocontine integrated printing plates are est in apposited printing plates are each apposed to plat or first mark using a mind that leaving though a signature. It is also first of 1.5 in digital transmission density plat 0.0 and an increase of 1.5 in digital transmission density per 0.0 and an increase of 1.5 in digital transmission density per on-step lineases. Each of the expected plates are undersided by the control of the second plates are declarated by the control of the second plates are declarated by the control of the second plates are declarated by the control of the second plates are declarated by the control of the second plates are declarated by the control of the second plates are declarated by the control of the plates present in the importance of the plates are declarated by the number of steps in an image obtained as a short in the second plates are declarated by the number of steps in an image obtained as short in the second plates are declarated by the number of steps in an image obtained as short in the second plates are declarated as an indicated control and other planes are declarated as an indicated and as a plane of the planes are declarated as a second plane.

Table 1

	Sulfonylamide Compound	Image Formability	Sensitivity
Example 1	Compound 1	clear image	8
Example 2	Compound 2	clear image	7
Example 3	Compound 4	clear image	5
Example 4	Compound 5	clear image	6
Example 5	Compound 12	clear image	6
Example 6	Compound 14	clear image	9
Comparative Example 1	absent	no image (dissolved completely)	-
Comparative Example 2	Compound A	no image (remaining entirely)	-
Comparative Example 3	Compound B	no image (remaining entirely)	-
Comparative Example 4°	absent	clear image	5

^{*:} Standard positive printing plate, VPS (made by Fuji Photo Film Co., Ltd.)

Compound A



Compound B



EXAMPLES 7 TO 10

A 0.0 mm/field durnifum jield (quility 1000) was depressed with incidence/jiven, and the surface benefit was applied with a right to the part of the country of the part of th

35 Composition of Subbing Solution:

β-Alenine	0.1 g
β-Alenine Methanol	40 g
A.W	ا ده ا

In the next place, but Solutions (A-1) to [A-4] were prepared to as to have the composition of sorbladd below as Composition of Solution (A), wherein the compounds according to the present invention were different in sort from emother. Each of Solutions (A-1) to [A-4] was coaled on the aluminum plate provided with the kneeping substing layer, and dried at 10°C for 2 minutes. Thus, positive working throughold plate meterials (A-1) to [A-4] were obtained. Therein, the dry coverage was 1.7 gives.

37

Composition of Solution (A)

Compound eccording to the invention (set forth in Table 2)

5	2,6-Bis(trichloromethyl)-4-(4-methoxy-1-naphthyl) -s-triazine (compound named PAG2-4 hereinbefore)	0.2 g
	Infrered absorbent NK-3508 (produced by Nippon Kanko Shikiso Kenkyusho K.K.)	0.15 g
	Novolek resin prepared from m/p-cresols and formaldshyde (m/p ratio: 8/2, weight-average molecular	2.5 g

Novoki rein prepared from mit-cresols and formaldshyde (mlp reto: 9/2, weight-average molecular veight: 5,800)
by (Victorie Pure Blue BOH having 1-raphthalene sulfonic add ion as its counter ion)
Megallic F-177 (Buorine-containing surfactent, produced by Dai-Nippon Ink & Chamicals, Inc.)
0.06 g

Megafac F-177 (filtorine-containing surfactent, produced by Del-Nippon Ink & Chamicals, Inc Matthy descriptions

rs 2-Methoxyethanol

0.05 g 0.06 g 20 g 7 g

100

The compounds used in Solutions [A-1] to [A-4] are set forth in Table 2.

Table 2
 Lithographic plats as

	Lithographic plate mate- rial	Compound used
Example 7	[A-1]	Compound 5
Example 8	[A-2]	Compound 8
Example 9	[A-3]	Compound 11
Example 10	[A-4]	Compound 7

The few detained positive vending throughout per less materials (x-1) to (x-4) were less for 5 days under a high temperature high temple coordine, separature high temperature high temperature of the control of the CPU Set Ref. Then flywer east excepted by means of VAC lass senting an interest on yell 1054 ms. After the exposure, the plate instate launderwest and exemited as health temperature of the material flower of the control of the CPU lands of the first flower of the control of the control of the CPU lands of the first flower of the control of the c

Table 3

	Lithographic plate mate- rial	Soum in non-image erea upon printing
Example 7	[A-1]	absent
Example 8	[A-2]	absent
Example 9	[A-3]	absent
Example 10	[A-4]	absent

EXAMPLES 11 TO 18 AND COMPARATIVE EXAMPLES 5 TO 8 Synthesis Example 1

Synthesis of resin having acid-decomposable groups (Compound [B-1]):

Poly(p-hydroxystyrene) (weight-average molecular weight: 9,600) in an amount of 9 g was dissolved in 100 ml of

dimethoxyethane, and thereto 12.6 g of 3,4-dihydro-2H-pyren and 0.5 ml of sulfuric acid were added. This solution was stirred for 15 hours at 30-40°C. After the reaction was completed, the reaction solution was concentrated under reduced pressure. The residue obtained was neutralized with sodium carbonate, and then poured into water to precipitate crystals. The crystels were filtered off, washed with water and dried under reduced pressure. Thus, 11.0 o of polylo-tetryly-5 dropyranyloxystyrene-p-hydroxystyrene) was obtained as white powder. The retio of the p-tetrahydropyranyloxystyrene units to the p-hydroxystyrene units in the polymer obtained was determined to be 3:7 by 1H-NMR enalysis.

Synthesis Example 2

10 Synthesis of resin having acid-decomposable groups (Compound [B-2]):

In an atmosphere of nitrogen, 22 g of the p-t-butoxycarbonyloxystyrene prepared in apportance with the method described in U.S. Patent 4,491,628 was polymerized in toluene at 90°C for 5 hours in the presence of 2,2° azobis/2,4dimethylvaleronitrile) catalyst. After cooling, the reaction solution was poured into methanol to deposit crystals. The 15 crystals deposited was filtered off, washed with methenol, end dried under reduced pressure. Thus, 15 g of poly(p-tertbut acycarbonylarystyrene) was obtained as white powder. A 7 g portion of this powder was dissolved in 1,4-diaxane, and thereto 10 ml of copc, hydrochloric acid was edded. This solution was refluxed with stirring for 2.5 hours. After cooling, the reaction solution was poured into water to deposit grystals. The thus deposited grystals was filtered off, washed with water, and dried under reduced pressure to yield 4 g of polyto-tart-butgovsarbonylgovstyrene-p-hydroxystyrene) as 20 white powder. The retio of the p-tert-butoxycarbonyloxystyrene units to the p-hydroxystyrene units in the polymer

Synthesis Example 3

obtained was determined to be 1:9 by 1H-NMR enalysis. as Synthesis of resin having acid-decomposable groups (Compound IB-3I):

Poly(p-hydroxystyrene) (weight-svaraga molecular weight: 9,600) in an emount of 12 g was dissolved in 120 ml of N.N-dimethylacetamide, and thereto 7 g of potassium carbonate end 9 g of t-butyl bromoscetate were added successively, followed by 7-hour stirring at 120°C. The reaction solution was treated in the same manner as that for the symso thesis of Compound (B-2) to yield a resin having the following structure. The retio of the acid-decomposable groupcontaining units to the p-hydroxystyrene units in the resin was determined to be 1:6 by 1H-NMR enalysis.

Synthesis Example 4

Synthesis of Dissolution Inhibitor (Compound (IN-11)

1-(a-methyl-a-(4'-hydroxyphenyl)ethyl)-4-(a',a'-bis(4"-hydroxyphenyl)ethylibenzene in en amount of 42.4 g (0.10 mole) was dissolved in 300 mi of N.N-dimetrylacetamids, and thereto 49.5 g (0.35 mole) of potessium carbonets and 84.8 g (0.33 mole) of curryl bromoscetate were added. The resulting solution was stirred for 7 hours at 120°C. The reaction mixtura obtained was poured into 2 liter of ion exchanged water, neutralized with ecetic ecid, and then extracted with ethyl acetate. The extract obtained was concentrated, and purified by column chromatography (carrier ss sitica gel, developing solvent: ethyl acetate/n-hexana (3/7 by volume) mixture). Thus, 70 g of the following compound (ell R groups were -CH₂COOC(CH₂)₂C₄H₆) was obtained.

Synthesis Example 5

35

Synthesis of Dissolution Inhibitor (Compound (IN-21):

a.u.d. of all "healthigh dishopping play" 1.3.5 Felliphipherane is an amount of 14.3 g (1.020 molt) was discoved in 120 of 16.7 Molth photospherane play and the control of 1.0 g (1.0 molth play 1.0 mol

Preparation and Evaluation of Photosensitive Compositions:

Each group of ingredients shown in Table 4 were dissolved in 6 g of diglims, and passed through a 0.2 jmmfilter to prepare each resist solution. This resist solution was coaled on a sillow refer by means of a spin coster receiving at 3,000 r.p.m., and dried for 60 seconds at 90°C on a hot plats of vacuum adsorption type, thereby forming a 1.0 µm-thick resist filtm.

The thus borned related time were each exposed by means of e.246 mm loff excinner leaser stepper (M.A.O.45). After the exposure, each of the films was bladed for 65 occords with a 110°C in pittled of vescular indestryption by an at once algoped for 60 seconds in a water solution of leteramethylummonium hydroxids (TMAH) (the concentration of which is described below). Further, it was missed with water for 50 seconds, and then dried. The hist to brond patterns on all-

con wafers were observed under a scanning electron microscope, end thereby the resist profile was evaluated. The evaluation results are shown in Table 5.

	Developer used
Examples 13 to 18	2.38 % TMAH
Comparative Examples 7 and 8	2.38 % TMAH
Example 11 and 12	1.19 % TMAH
Comparative Examples 5 end 6	1.19 % TMAH

The sensitivity was defined as the reciprocal of the exposure amount required for the reproduction of a 0.50 µm mask pattern, and the sensitivity values shown in Table 5 are relative values, with Comparative Example 1 being taken as 1.0.

The film shrinkage was expressed in terms of the percentage of the ratio between the film thicknesses in the exposed area before and after the post exposure bake.

The resolution was represented by the limiting resolution under the exposure amount required for the reproduction so of a 0.50 jum mask patient.

The rests profe was evaluated by the engle (6) of a resist side wall formed with the silicon water plane in the cross

section corresponding to a 0.50 µm mask pattern.

40

41

Example	Binder resin	added (g)	N-sulfon- added	added (g)	tion in- added	added (9)	acid added	added	
11	Poly(P-hydroxystyrene)	1.4	Compound 1 0.60	1 0.60	٠		PAG3-1	0.05	
12	ditto	*:	Compound 2	2 0.6	1-N-1	0.30	PAG4-2	0.05	
13	p-Hydroxystyrene/styrene 1.4	1.4	Compound 5	5 0.7	1		PAG4-1	0.05	
77	(8/2) copolymer, mw=25,000 ditto	*:	Compound 6	8.0 9	IN-2	0.30	PAG4-1	0.05	
15	B-1	1.4	Compound 10	10 0.60	•		PAG5-2	9.02	
16	B-2	1.4	Compound 12 0.60	12 0.60	ď		PAG3-2	9.02	
11	B-3	1:4	Compound 14	14 0.60			PAG4-3	0.05	
87	ditto	1.4	Compound 17 0.30	17 0.30	IN-2	0.30	PAG4-2	90.0	
Compar.	Poly(p-hydroxystyrene)	1.4	,		18-1	0.60	PAG4-1	0.05	
Ex. 6	ditto	1.7	•		ditto	0.30	PAG3-1	0.05	
Ex. 7	B-3	1.4	•		114-2	09.0	PAG4-1	0.05	
-									

ditto

ditto

			Table 5		
		Reletive sensitivity	Film shrinkage	Resolution (µm)	Resist profile (6)
. 1	Example 11	1.3	1 %	0.27 [0.26]	87*
	Example 12	1.5	2%	0.27 [0.30]	88*
	Example 13	1.7	1%	0.25 [0.25]	89*
	Example 14	1.8	2 %	0.26 [0.28]	88*
۰	Example 15	1.4	1%	0.24 [0.25]	88*
	Example 16	1.5	1 %	0.24 [0.25]	88*
- [Exemple 17	1.8	1 %	0.25 [0.24]	89°
۱ ،	Example 18	1.5	1%	0.26 [0.27]	87"
	Compar. Ex. 5	1.0	4 %	0.31 [0.37]	83*
	Compar. Ex. 6	1.2	2%	0.33 [0.45]	78*
	Compar. Ex. 7	0.6	4 %	0.30 [0.40]	84*
100	Compar. Ex. 8	0.8	4%	0.32 (0.45)	80*

Resolution (µm): The unparenthesized values are resolutions determined under a condition that the resist time were taken to based immediately after the expource end then developed, while the values in the precioles are resolutions determined under a condition that the resist films were allowed to stend for 30 minutes effer the exposure, based and then developed.

As can be seen from Table 5, the present resist first were less in tim shrivings due to post exposure beliefs and held better profits, higher sensitivity and higher resolutions than the comparisher setted firms. There, they present settle films were almost free from the deterioration in resolution due to the time passing from the exposure till the heat treatment, indicating that they had excellent stability.

EXAMPLES 19 AND 20

30 The series of 9.00 mm brick charmon pides was gained with a right host and a visit supprising of permis-product of 0.00 mm brick, and throughly visit self-prising pides of visit submitting pides was lettered by being depet for 0.00 excords in 1.0 % sodium hydroids coldicin legict at 170°C, followed by wearhing with ununing water. Further, the alternitum pides was self-prising through the condition of the coldinary pides of the coldinary pides was self-prising through the coldinary of the dominant pides was consist and in a 1.8 was self-prising the pides of the coldinary of the dominant pides was consist and in a 1.8 was self-prising the coldinary of the coldinary depth of th

of 2 Ardm² so as to have a thickness of 2.7 g/m².

On the thus prevend alturnium support, each of the following photosensisive solutions A and B was coated using a whiter of a rotation social of 200 r.p.m., and dried for 1 minute at 100°C.

Composition of Photosensitive Solution A (Example 19):

N-Sulfonylamide polymer (P-4) of Synthesis Example B-1	5 g
4-p-Tolylmarcapto-2,5-diethoxybenzenedlazonium hexadluorophosphata.	0.5 g
Dibutytin laureta	0.03 g
Diethylane glycol dimethyl ether	40 g
Methyl ethyl ketone	100

Composition of Photosensitive Solution B (Example 20):

N-Sulfonylamide polymer (P-5) of Synthesis Example B-2	3.2 ç
Phthalic acid anhydride	5 mg
o-Chlorophenol	1 mg
4-p-Tolytmercapto-2,5-diethoxybenzenediezonium hexafluorophosphate	0.3 g
Diethylene glycol dimethyl ether	27 0
Methyl ethyl ketone	10 0

- The presensitized plate having a coating of Photosensitive Solution B was further heated for 1 hour at 140°C.

 Then, each plate was subjected to 500 count exposure by means of a printer, Al Rotery Printer (made by Al Graph-
- ics Co., Ltd.).
 After the exposure, each plate was subjected to one-minute heat freatment and, without undergoing any development-processing, set in an offset printer, followed by printing operations.
- Thus, 8,000 sheets of sour-free prints were obtained in the case of using the printing plete having a coating of Photosensitive Solution A; while 6,000 sheets of sour-free prints were obtained in the case of using the printing plate having a coating of Photosensitive Solution 8.

EXAMPLES 21 TO 25

ro

If A 100 arthick stainless pitel was costed with a styrone-butadions rein (1% lobuse solution, Cauton 1900 x, commercial name, a product of Shell OC company Lsb, and heated of 170°C. To this support, the following photosensitive solution containing an N-autonylamida polymar was applied, dried for 1 minute at 100°C, and further heated for 1 hour et 140°C.

at Composition of Photosensitive Solution:

N-Sulfonytamide polymer shown in Table 6	3.2 g
Phthalic enhydride	5 mg
o-Chlorophenoi	1 mg
2,6-Bis(trichloromethyl)-4-(4-methoxy-1-naphthyl) -s-triazins (Compound named PAG2-4 hereinbel	lore) 0.3 g
Infrared absorbent NK-3508 (produced by Nippon Kanko Shikiso Kenkyusho K.K.)	0.15 g
Dye (Victoria Pure Blue BOH heving 1-naphthalene sulfonic acid ion as its counter ion)	0.05 g
Megafac F-177 (fluorine-containing surfactant, produced by Dai-Nippon Ink & Chemicals, Inc.)	0.06 g
Methyl ethyl ketone	5 0
1-Methoxy-2-propanol	15 0

The has obtained lithographic plate materials were large for Super, under a high interpretation high handing condition, specifically under condition of \$400.75 EM. Then, they were also expected by material of \$400.86 ex entiring an interest any of 1046 ms. After the exposure, the plate materials underword convenients that therefore at 1100.00 ms. whost of produced recovering, they were each subjected to printing operations with a present of a continuous contractions of the second object of the contraction of the second object of the second object

The number of printed sheets having no scumming are shown in Table 6.

Table 1

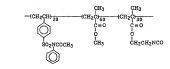
Example	N-Sulfonylamide Polymer	Number of Printed Sheets
3	P-1	30,000
4	P-2	42,000
5	P-3	55,000
6	P.7	40,000
7	P. 0	45 000

COMPARATIVE EXAMPLES 9 AND 10

In the same manner as in Exemples 21 to 25, except that the following polymers were used respectively in place of the present NeutroPhysimide polymers, printing plates every produced, and then exposed, hated, set in the surre press, Heidel NOP-D, without development-processing, and subjected to printing operations. All the printed matters thus deblaced had so currently in all areas, including image excess end non-timose areas.

Polymer used in Comparative Example 9

O Polymer used in Comparative Example 10



The figures in the foregoing structural formulas are mole fractions.

EXAMPLES 26 TO 29 AND COMPARATIVE EXAMPLES 11 TO 13

15

On the same support as used in Example 19, the following photosensitive solution was coated and dried for 2 minutes at 100°C.

N-Sulfonylamide polymer shown in Table 7	1.5 (
m/p-Cresol resin (nvip ratio: 6/4)	3.0 g
4 p-Tolytmercapto-2,5-diethoxybenzenediazonium hexafluorophosphete	
Crystal Violet	0.01 g
Mothyl ethyl ketone	18 g
1-Methoxy-2-propanol	6 9

This day coverage of the photosembles acidion was £1, pilm? The that obtained photosembles throughts pointing plates were such accounted to jill of the intrinse using a metal basis leavy as an implicable. Fig Step Dubles (make the point of the plates) and the property of 50 step in the plate of the plates o

Table 7

	N-:	sulfonylamide Polymer	Image Formability	Sensitivity
Example 26		P - 8	clear image	6
Example 27		P - 9	clear image	8
Example 28		P - 13	.clear image	7
Example 29		P - 14	clear image	8
Comparativ Example 11	е	absent (no image dissolved completel	- -
Comparative Example 12		absent	clear image	5
(٠.	Standard pos VPS (produce Ltd.), was t	sitive working printed by Fuji Photo Fi	ting plate, lm Co.,

Comparative N-sulfonylamide no image Example 13 polymer shown below

The results obtained in Examples 19 to 25 demonstrate that the production of original plates without requiring descriptionart-processing has been effected by using the photosensitive compositions comprising polymers having Nsuthon/samilog groups according to the present invention.

On the other hand, the results obtained in Exemples 26 to 26 show that the original plates having high secultivity and excellent image formability hands been prepared by using the photocentiels compositions complising polymes having household by such that the prepared by the prepared b

The positive image forming compositions according to the present invention can provide resist compositions which or ensure high sensitivities and a reduction in time shrinkage due to post appeare basing, assistancing profile and high recultion, and hashly sutter destrictation in resolution due to the time passage from the appeares to the activations and the activation in the activation in the activation in the activation and the activation of the activation and the activation activation and the activation activation and the activation activation

In occordance with present invention, a lithographic plate capable of proving soun-free printed matters is produced without performing development-processing left erapouter. Further, the present invention can provide a printing plate having high sensitivities to legis of longer wavelengths, persoularly to visible light and infrared leser beams, high stability upon storage, and no sours in normingae areas.

Claims

 A positive image forming composition comprising (a) a compound generating an acid by undergoing the action of light or heat end (b) et least one compound selected from the N-sulfonyiernice compounds represented by the following formula (f) or (file).

$$L_1 - (SO_2 - NR_2 - CO - R_1)_n$$
 (I)

wherein n is an integer of from 1 to 8; R₁ represents an eromatic group or an allyligroup; L₁ represents an eromatic group or an allyligroup when n is 1, or L₁ represents a polyvalient linkage group constituted of normatial atoms when n is 5 cm 2 to 8; and R₂ represents a tentary allyligroup, an allowymethyligroup, an anythestyligroup or an allyligroup in the strong to 8; and R₂ represents a tentary allyligroup, an allowymethyligroup, an anythestyligroup or an allyligroup.

- A positive image forming composition eccording to daim 1, wherein the N-sulfonylemide compound of formula (I)
 or (II) contains as R₂ a I-butyl group or a 2,2-dimetryl-4,4-dimetryloutyl group.
- A positive image forming composition eccording to claim 1, wherein the N-sulfurylemide compound of formula (f) or (fi) contains as R₂ e benzylczymethyl group, a methocymethyl group, a 2-ethoxyethyl group, a methocyyethoxymethyl group, el tetrehydrocymeth croup or a fetharhydroupenin group.
- A positive image forming composition according to daim 1, wherein the N-sultonylamide compound of formula (i) or (ii) contains as fig. a p-methoxybenzyl group, a 24,6-trimethoxybenzyl group, a piperonyl group or a 9-enthranylmethyl group.
 - A positive image forming composition according to claim 1, wherein the N-sulforsytemide compound of formula (I)
 or (II) contains as R₂ e cyclohexyl group or a dibenzousberyl group.
- 25 6. A positive image torming composition according to any one of claims 1 to 5, what ein the acid generaling compound (a) is at least one compound selected from the group consisting of oxadiazote compounds having tribalometryl substitutes, a Fluidarce compounds having tribalometryl substituents, lodonium salts, sutfortium salts, diazonium salts, disulfone compounds and intrinsultionate compounds.
- 7. A positive image terming composition according to any one of claims 1 to 8, further comprising (a) a high melecular organic binder which is insoluble in water but soluble or et least swellable in en equeues eliasine solution.
 8. An image ferming composition comprising (a) a compound samesting an add by undersoling the action of light or

heat and (c) e polymer having constitutional units represented by the following formula (III):

wherein R₃ represents a tertiary alkyl group, an alkoxymethyl group, an arylmethyl group or an alicyclic alkyl group.



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Cetegory	Citation of document with indica of relevant passages	tion, where appropriate,	Relevant to claim	CLASSFICATION OF THE APPLICATION (INICIA)
A .	DE 42 42 051 A (HOECH * page 6; table 1 * * claims *	ST AG)	1-7	G03F7/004 G03F7/039
١	DE 42 42 050 A (HOECH: * page 7; examples 21 * claims *	ST AG)	1-8	
	DATABASE MPI Section Ch, Week 8924 Derwent Publications Class A89, AN 89-1754; XP002042198 & JP 01 114 861 A (FU, 8 May 1989 * abstract *	Ltd., London, GB; 8 DI PHOTO FILM CO LTO)	8	
				TECHNICAL FIELDS SEARCHED BYLCLE
				GO3F
	The present search report has been	drawn up for all claims		
	THE HAGUE	30 September 1997	J 3	M. DUPART
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